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Date: Feb. 11, 2004

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Art Unit: 1756

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Subject Matter: 10/ 047,266 Attorney Doc: 67,200-641

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Applicant(s): Chih-Ming Ke

Application No.: 10/047,266 (CONF 4511)

Filed: 1/14/2002

Title: Reducing photoresist shrinkage via plasma treatment

Group Art Unit:
1765Examiner:
Kim Chan Chen

Attorney Docket No.: 67,200-641

Commissioner for Patents
Alexandria, VA 22313-1450Certificate of Facsimile Transmission

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Patent Office via facsimile no. (703) 872 9311 on the date shown below.

Date: Feb. 11, 2004

Kathy Dixon

REQUEST FOR RECONSIDERATION

Dear Sir:

In response to a final Office Action dated Dec. 11, 2003, please enter the following amendment and consider the following remarks.